



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 7449**  
Kazuhiro OTSU et al. : Docket No. 2002\_0208A  
Serial No. 10/067,370 : Group Art Unit 2818  
Filed February 7, 2002 : Examiner Thao P. Le

SEPARATING MACHINE FOR THINNED  
SEMICONDUCTOR SUBSTRATE AND  
SEPARATION METHOD

THE COMMISSIONER IS AUTHORIZED  
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**SUBMISSION OF FORMAL DRAWINGS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with Patent Office practice, submitted herewith are formal drawings for  
Figs. 1-5 (2 sheets, A4 Paper).

Respectfully submitted,

Kazuhiro OTSU et al.

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Fig.1

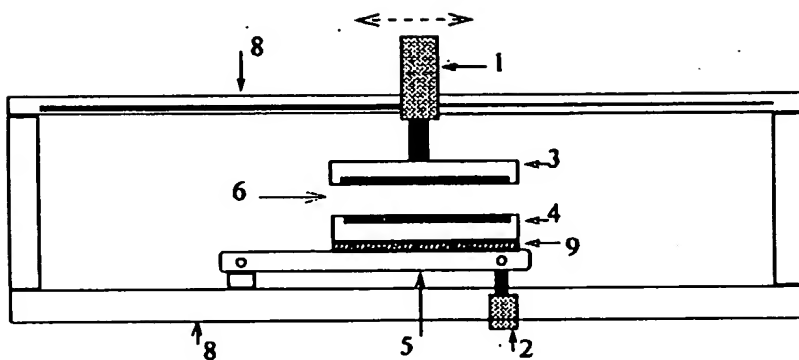


Fig.2

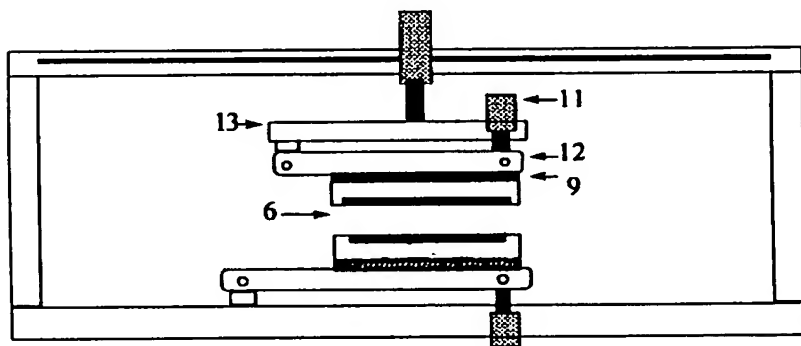


Fig.3

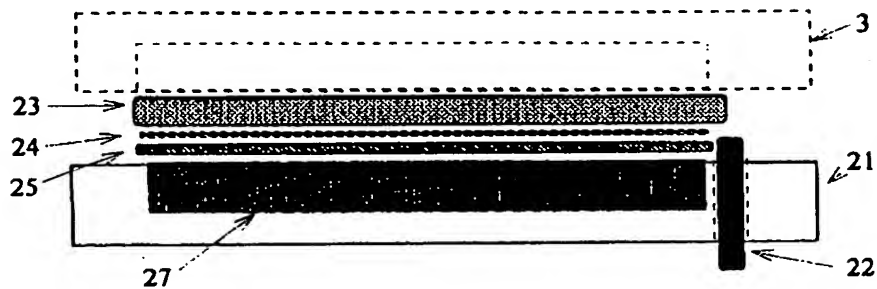


Fig.4

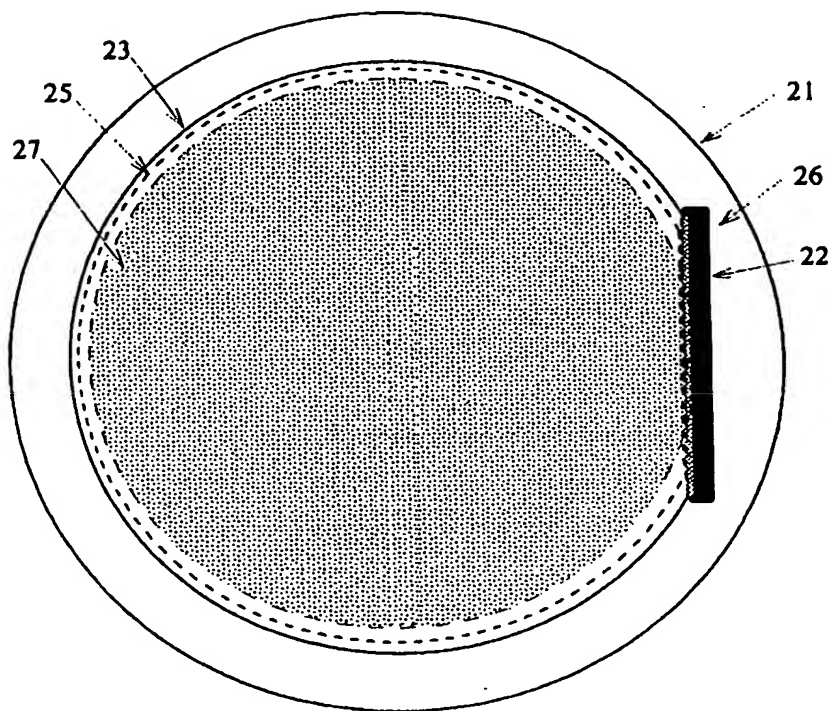


Fig.5

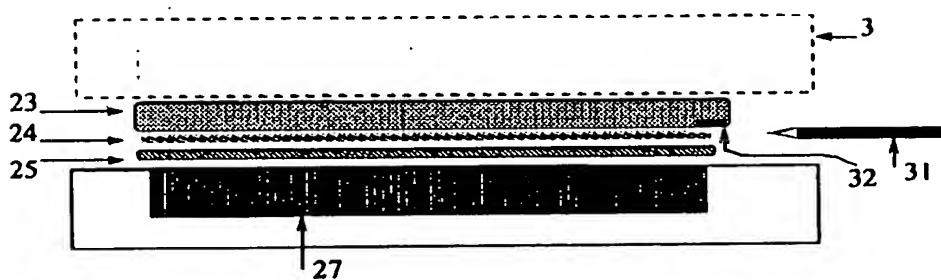


Fig.6

